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# Electric pulse induced electronic patchwork in the Mott insulator $\text{GaTa}_4\text{Se}_8$

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Following a recent discovery of the Insulator-to-Metal Transition induced by electric field in  $\text{GaTa}_4\text{Se}_8$ , we performed a detailed Scanning Tunneling Microscopy/Spectroscopy study of both pristine (insulating) and transited (conducting) crystals of this narrow gap Mott insulator. The spectroscopic maps show that pristine samples are spatially homogeneous insulators while the transited samples reveal at nanometer scale a complex electronic pattern that consists of metallic and super-insulating patches immersed in the pristine insulating matrix. Surprisingly, both kinds of patches are accompanied by a strong local topographic inflation, thus evidencing for a strong electron-lattice coupling involved in this metal-insulator transition. Finally, using a strong electric field generated across the STM tunneling junction, we demonstrate the possibility to trig the metal-insulator transition locally even at room temperature.

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Many correlated materials exhibit exotic properties like metal-insulator transitions (MIT) in transition-metal oxides or chalcogenides, high- $T_c$  superconductivity in cuprates, colossal magnetoresistance in manganites. These phenomena are frequently associated with spatial electronic inhomogeneities or even electronic phase separation. The presence of patches with different magnetic, metallic or insulating nature was demonstrated in many real-space studies of systems such as manganites [1–3], cuprates superconductors [4–8],  $\text{VO}_2$  [9–12], Ca substituted  $\text{Sr}_2\text{RuO}_4$  [13]. Generally, in these systems, the MIT is induced by tuning either the hopping amplitude via pressure (*bandwidth-controlled* transition) or band-filling via chemical doping (*doping-controlled* transition) [16]. In addition to these ways of controlling the electronic state of correlated materials, we recently discovered that short electric field pulses could also drive the MIT in the Mott insulator  $\text{GaTa}_4\text{Se}_8$  [17–19]. Such a new way to electrically induce a MIT might be interesting for electronic devices, in particular if this MIT can be controlled at the nanometer scale at room temperature.

The Mott insulator  $\text{GaTa}_4\text{Se}_8$  adopts a deficient spinel structure (Fig.1a) of rocksalt-type packing of  $\text{Ta}_4\text{Se}_4$  cubanes and  $\text{GaSe}_4$  tetrahedra [20, 21]. This compound belongs to a specific class of Mott insulators in which correlations do not take place at the atomic scale but rather at the scale of the  $\text{Ta}_4$  clusters [22]. This makes these compounds easier to tune through the Metal-Insulator-Transition as it reduces the magnitude of Coulomb repulsion.  $\text{GaTa}_4\text{Se}_8$  is a rare example of stoichiometric Mott insulator that undergoes a pressure-induced MIT and even a superconductor transition [20]. Recently we found that an electric field pulse through  $\text{GaTa}_4\text{Se}_8$  induces a MIT (see Fig.1b), accompanied at low temper-

ature by granular superconductivity [17, 23]. While the microscopic origin of this effect remains undecided, it was experimentally found in [23] that the temperature evolution of the resistance on the metallic side of the MIT in single crystals of  $\text{GaTa}_4\text{Se}_8$  can be accounted for by a two channel model of a *granular metal* in an insulating matrix. In this Letter report a detailed Scanning Tunneling Microscopy and Spectroscopy (STM/STS) study of this material on both sides of the MIT. On the insulating side we observed spatially homogeneous tunneling characteristics whereas on the metallic side of the transition the samples revealed nanometer scale electronic inhomogeneities accompanied by a strong local deformation. Moreover, we demonstrate the possibility to induce the MIT locally using the electric field generated across the STM junction.

Single crystals of  $\text{GaTa}_4\text{Se}_8$  of typical sizes around  $300\ \mu\text{m}$  were obtained by the selenium transport method [17]. The main steps for the preparation of the transited crystal used in this STM/STS study are summarized in Fig.1b-d. First, two electric contacts were glued onto small  $\text{GaTa}_4\text{Se}_8$  single crystals of  $\sim 300$  microns (Fig.1c). As expected for a Mott insulator, the resistance of the pristine sample displays a semiconducting/insulating behavior (see red curve in Fig.1b). Application at 60 K of an electric field of about  $30\ \text{kV/cm}$  to this crystal induces a non-volatile MIT. After the electric pulse, the transited crystals present a low resistance state (see blue curve in Fig. 1b).

The crystals were then cleaved with a blade as sketched in Fig.1d in order to obtain clean (100) surfaces. The cleavage plane was chosen in order to have the external electrode axis parallel to the cleaved surface. After the cleavage the samples were immediately introduced

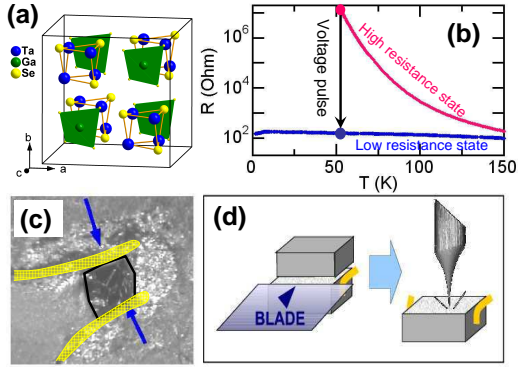


FIG. 1: (Color online) (a) Representation of the crystal structure of  $\text{GaTa}_4\text{Se}_8$  enhancing metal-metal bonding in the clusters (violet) Ta atoms : red, Se atoms : yellow, Ga-centered tetrahedra : green. (b) Temperature dependance of the resistance of the crystal used in this study. Red curve : before electric pulse, Blue curve : after electric pulse. (c) Photograph of the cleaved crystal used in this study. The arrows indicates the position of the external electrodes used to transit the crystal. (d) Schematic representation of the cleaving protocol.

to the ultrahigh vacuum chamber (base pressure below  $3.10^{-11}$  mbar) holding the STM unit. The STM/STS experiments were provided at room temperature using electrochemically etched tungsten tips, thermally annealed under vacuum by direct current heating. The tunneling conductance  $dI/dV(V)$  spectra were obtained by direct numerical derivation of the raw  $I(V)$  spectra.

The large scale topographic STM images acquired on cleaved pristine crystals show atomic terraces which are several hundred of nanometers wide (Fig.2a) [17]. The step heights are 0.5 nm, or its multiple, which corresponds to the thickness of slabs of  $\text{Ta}_4\text{Se}_{16}$  clusters and  $\text{GaSe}_4$  tetrahedra (Fig.1a). However, besides these steps, the topographic images of pristine  $\text{GaTa}_4\text{Se}_8$  crystal remains structureless as seen in figure 2c. The figures 2d-e present two conductance maps, taken at -600 mV and at 0 mV (Fermi level) respectively, which are extracted from the full  $dI/dV(V)$  STS data set taken on the area of figure 2c. These maps reveal a spatially homogeneous insulating state. Typical conductance spectra, displayed in figure 2b, present a strong suppression of spectral weight around zero bias that is expected due to the gap at the Fermi level in the Mott insulating state. These data are consistent with the results of the optical conductivity measurements [24] that pointed out a gap of  $\sim 100$  meV. Note, that since the STS experiments were conducted at room temperature, the thermal broadening of  $3.5k_B T \simeq 90$  meV affected the tunneling character-

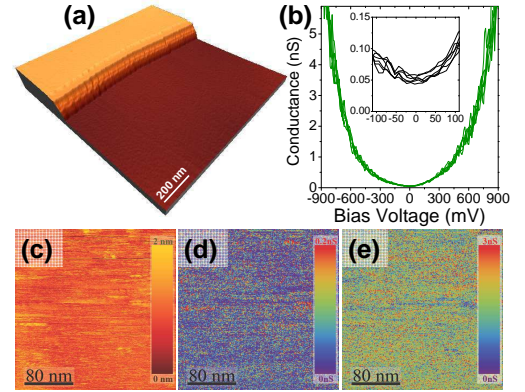


FIG. 2: (Color online) (a) Topographic STM image ( $V_T = -600$  mV,  $I_T = 100$  pA) of the surface of a cleaved pristine crystal. (b) Representative  $dI/dV$  spectra acquired on the surface from panel (c-e). The image (c) is a small scale topographic image ( $V_T = -600$  mV,  $I_T = 300$  pA). The images (c,d) show the corresponding homogeneous conductance maps at -600 mV (d) and 0 mV (e).

istics resulting in a smeared apparent gap and a finite conductance at zero bias, as shown in the inset of Fig.2b.

If we now look at the STS data acquired on transited (metallic side) crystals, we find a very different picture (Fig.3). First of all, the surface of transited  $\text{GaTa}_4\text{Se}_8$  crystals reveals specific topographic features at a scale of few tens of nanometers (see Figs.3a and 3f) which are absent in the pristine samples. We observed elongated blobs, with characteristic sizes 30-50 nanometers, organized in filaments and oriented along the direction of the electric field applied during the transition procedure via external electrodes. Second, the analysis of  $dI/dV(V)$  conductance maps evidences that the MIT induced a complex electronic patchwork corresponding to the electronic phase separation at the nanoscale (Fig.3b-d). The first conductance map is taken at a voltage of -600 mV well above the gap (Fig.3b), the second one is taken at -200 mV around gap edge (Fig.3c) and the last one at the Fermi level (Fig.3d). These conductance maps are strongly inhomogeneous. As underlined in figure 3c we encountered three typical zones: A (green), B (violet) and C (red) that correspond to three different electronic states which respective conductance spectra are displayed on Fig.3e. Some conductance spectra corresponding to the zone A are featured in green. They are insulating-like and very similar to those observed in the pristine material, hence suggesting that these zones are barely affected by the electric pulse induced MIT. Spectra from the zone B, depicted in violet, have no conductance at zero bias ( $dI/dV(0)=0$ ), and their corresponding gap of  $\sim 400$  meV is significantly larger than the gap in

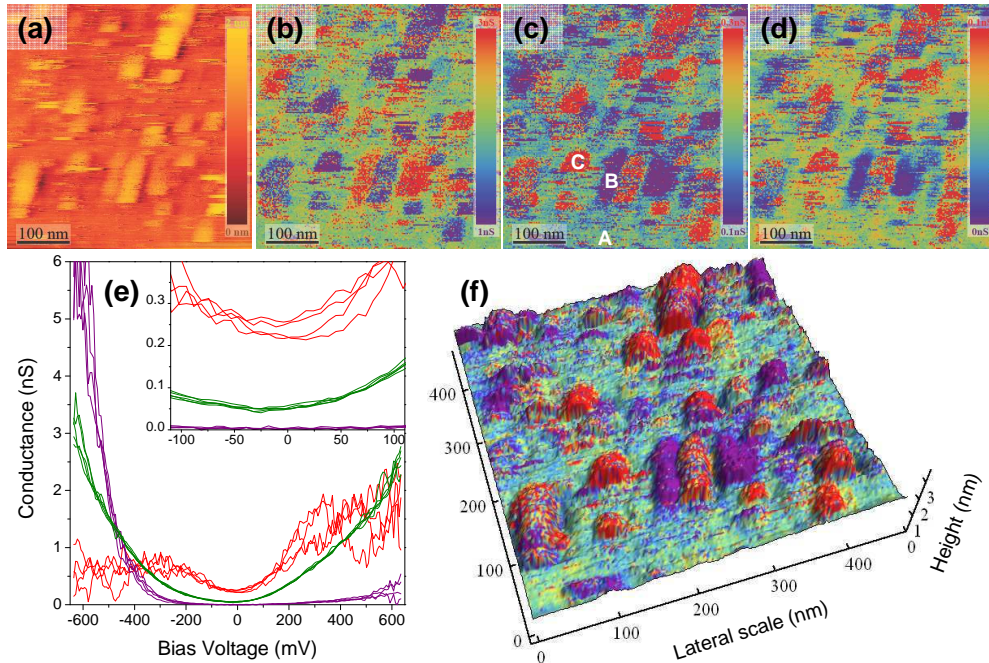


FIG. 3: (Color online) (a) Topographic image of a cleaved transited  $\text{GaTa}_4\text{Se}_8$  crystal ( $V_T = -550$  mV,  $I_T = 250$  pA). The figures b-d are the corresponding conductance map taken at -600 mV (b), at -200 mV and at the Fermi level 0 mV. These maps show clear electronic inhomogeneities. The figure (e) show the tunneling spectra corresponding to the zones A (green), B (violet), C (red) depicted on image c. The  $dI/dV$  spectra of the zone A (in green) are similar to the one of the insulating pristine samples, the spectra from zone B (violet) are more insulating and hence are called super-insulating while the spectra from zone C (in red) are ‘metallic like’. In figure (f) the relief correspond to the topography while the color correspond to the conductance at -200 mV. This figures show clearly that the ‘metallic’ and super-insulating zones are topographically inflated.

the pristine state. As they are more insulating than the pristine insulating medium we call these regions ‘super-insulating’. Spectra from the zone C, represented in red, evokes those of a bad metal with a finite density of states at the Fermi level; hence these spectra will be qualified as ‘metallic’. Interestingly, a contrast inversion appears between metallic and super-insulating patches when the maps acquired at voltages -200 mV (Fig.3c) and -600 mV (Fig.3b) are compared. This is due to the fact that the super-insulating patches are marked by a very low density of states below  $\pm 300$  meV, while at -600 meV they represent the dominant contribution. On the contrary, the metallic patches, which density of states dominates at the Fermi level, have a lower density of states at -600 meV. It is also worth noting that both ‘metallic’ and ‘super-insulating’ spectra show an asymmetry between occupied and unoccupied states (*i.e.* between negative and positive bias voltage), whereas insulating spectra are almost symmetrical. Such an electronic patchwork is rep-

resentative of the whole surface and has been encountered in numerous locations close or far from the macroscopic electrodes. This supports the conclusion drawn from four contact resistivity measurements [17] that the resistive switching in  $\text{GaTa}_4\text{Se}_8$  is globally a *bulk* effect: It is not related to any interfacial phenomenon to occur near the external electrodes used to transit the sample.

It is quite striking to observe that the topographic inhomogeneities (Fig.3a) that appear through the pulse induce MIT transition, absent in the pristine material, are perfectly correlated to the induced metallic and super-insulating patches, as demonstrated on the 3D topography/spectroscopy map of Fig.3f. In this image the 3D channel corresponds to the topography and the color channel corresponds to the conductance map at -200 mV. It is clear from this picture that the material inflates where new electronic patches appear, indicating that a very strong electron-lattice coupling is involved in the MIT. This strong electron-lattice coupling is reminiscent

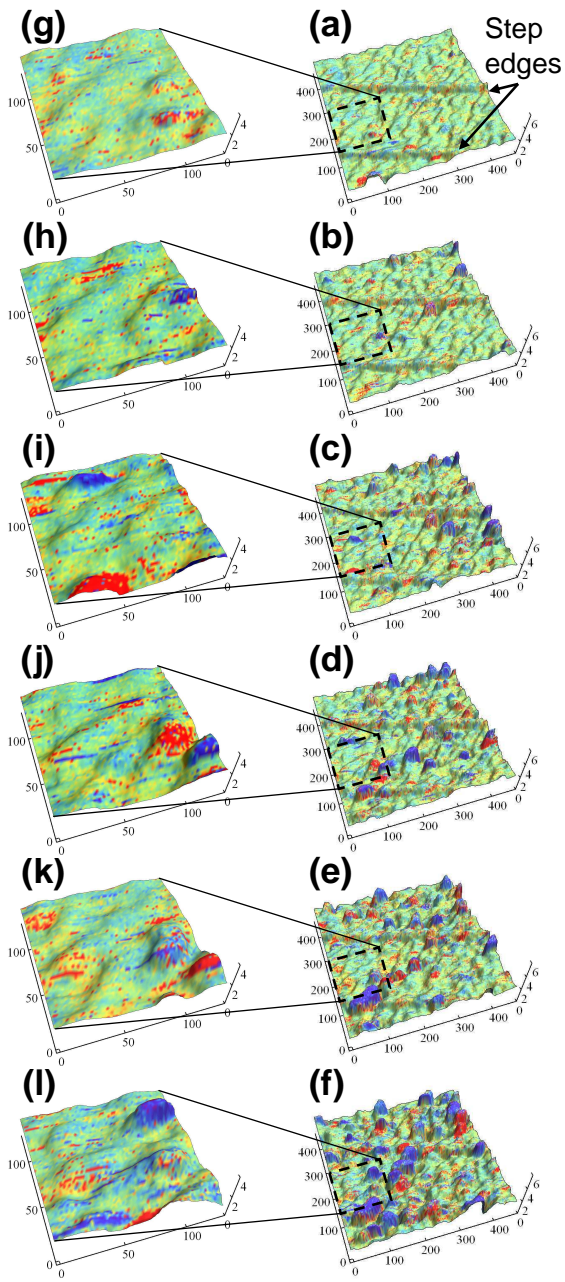


FIG. 4: (Color online) The right part from a to f displays a series of consecutive Topographic/Spectroscopic measurements conducted on the same area (scale in nm). The topography was acquired with at  $V_T = -630$  mV,  $I_T = 250$  pA. The 3d canal correspond to topography while the color canal correspond to the conductance map at -200 mV. The left part of the figure, from g to l, show zooms on a same area, where switchings between insulating, metallic and super-insulating state are observed during consecutive frames. The topography is clearly correlated to the local electronic transitions.

of the volume change encountered in the Mott metal-insulator transition such as in the canonical Mott insulator  $V_2O_3$  [25].

We have therefore strong indications that the electric field applied with macroscopic external electrodes (Fig.1) creates an electronic phase separation concomitant to strong local sample deformations. At this step we may also expect that the strong electric field generated by the STM tip could locally modify the electronic state. Figure 4 shows successive topographic/spectroscopic maps measured on the *same* location of a transited crystal. The successive topography and conductance maps reveal that between two consecutive measurements, some zones switch back and forth between the super-insulating, insulating and metallic states (see the zooms on figure 4). Such switchings however, while being certainly due to an interaction between the STM tip and the sample, are not observed during purely topographic measurements, even after consecutive scans over 24 hours, if the bias voltage was kept lower than  $\sim 700$  mV. The fact that the switchings are observed only during spectroscopy measurements indicates that the electronic phase separation in  $GaTa_4Se_8$  is strongly affected by the voltage sweeps ( $\pm 1V$ ) applied through the STM tip. This supports the existence of a threshold field, in agreement with the conclusions of macroscopic experiments [18, 19]. Finally we note that the use of high voltage pulses ( $\sim 2$  V) well above the threshold voltage to selectively induce new electronic phase appears to be impossible since the local inflation of the material during the pulse is so strong that the surface ‘jumps’ to the tip at every pulse and provokes tip crashes [26].

In conclusion, the comparison of our STM/STS data acquired on pristine and transited crystals gives a direct experimental evidence that the electric-field-induced metal-insulator transition recently observed in  $GaTa_4Se_8$  arises from the formation of a nanoscale electronic phase separation. The pristine crystals are homogeneous while the transited crystals display a peculiar electronic patchwork with a filamentary structure, that consists of a metallic/super-insulating network embedded in a barely pristine insulating matrix. The induced electronic inhomogeneities are associated with local topographic inflations indicating an important strain effect in the induced phase separation, probably originating from a strong electron-lattice coupling. The electronic phase separation can be reorganized by the electric field of the STM tip, suggesting that a local electric field might be used in this correlated systems to tune the Mott metal-insulator transition at the nanometer scale at room temperature.

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